

Docket No.: 79684-US1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Francis J Kub et al.

Application No.: 10/022364

Confirmation No.: 3513

Filed: December 20, 2001

Art Unit: 2823

For: Method for transferring thin film layer material to
a flexible substrate using a hydrogen ion splitting
technique

Examiner: G. R. Fourson

AMENDMENT IN RESPONSE TO OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated February 22, 2006, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.